



511.40998X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: N. KOYAMA et al.

Serial No.: 10/018,188

Filed: December 18, 2001

For: CMP ABRASIVE, METHOD FOR POLISHING SUBSTRATE
AND METHOD FOR MANUFACTURING SEMICONDUCTOR
DEVICE USING THE SAME, AND ADDITIVE FOR CMP
ABRASIVE

Group AU: 3724

Examiner: T. Eley

Confirm. No.: 7930

PETITION FOR EXTENSION OF TIME

Commissioner For Patents

P.O. Box 1450

Alexandria, VA 22313-1450

August 15, 2006

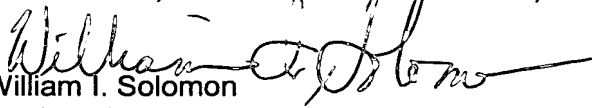
Sir:

In the matter of the above-identified application, applicants hereby respectfully petition for an extension of time to permit filing a response within the second month subsequent to expiration of the shortened statutory period set in the outstanding Office Action mailed March 15, 2006. A Credit Card Payment Form in the amount of \$450.00 to cover the required fee for the requested extension of time is attached hereto.

It is respectfully requested that any shortage in the fee be charged to the account of Antonelli, Terry, Stout & Kraus, LLP, Account No. 01-2135 (Case No. 511.40998X00).

Respectfully submitted,

ANTONELLI, TERRY STOUT & KRAUS, LLP


William I. Solomon
Registration No. 28,565

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